

Prof. Do Hwan Kim

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Prof. Do Hwan Kim currently serves as a Distinguished Professor in the Department of Chemical Engineering at Hanyang University, Republic of Korea. He earned his PhD in Chemical Engineering from Pohang University of Science and Technology in 2005. From 2006 to 2010, he held the position of senior researcher at the Samsung Advanced Institute of Technology. Additionally, he worked as a postdoctoral fellow in the Department of Chemical Engineering at Stanford University in the United States from 2011 to 2012. Subsequently, he served as an Assistant Professor at Soongsil University, Republic of Korea, from 2012 to 2017. His research interests span the fields of stretchable or ultrahigh-resolution organic microdisplays, multimodal electronic skins, iontronic synaptic devices for robot skin, and implantable iontronic neurostimulator/wound healing patches.